Itel

Docket No.: 50432-330

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Minh Van NGO, et al.

Confirmation Number: 1043

Application No.: 10/774,418

Group Art Unit: 2812

Filed: February 10, 2004

Examiner: Berry, Renee R

For: METHOD OF TREATING INLAID COPPER FOR IMPROVED CAPPING LAYER

ADHESION WITHOUT DAMAGING POROUS LOW-K MATERIALS

REQUEST FOR RECONSIDERATION

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Reconsideration of the rejection under 35 U.S.C. § 103 imposed in the Office Action dated October 7, 2004 is solicited in light of the following Remarks.